

Docket No.: F03-354-USDiv
FUJIT.044DIV



IFW

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re patent application of

Hisaki KATO, et al.

Serial No.: 10/634,836

Group Art Unit: 2822

Filed: August 6, 2003

Examiner: Keisha L. Rose

For: LIGHT-EMITTING SEMICONDUCTOR DEVICE USING GALLIUM
NITRIDE COMPOUND SEMICONDUCTOR

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

**REQUEST FOR CONSIDERATION OF
INFORMATION DISCLOSURE STATEMENT**

Sir:

Applicants respectfully submit that notification of consideration of the references submitted with the Information Disclosure Statement and Form PTO-1449 filed July 6, 2005 (copy enclosed), has not yet been received. A copy of the date-stamped postcard is also enclosed. Applicants respectfully request that these references be considered by the Examiner and formally made of record in this application, and that notification of such consideration be issued.

Respectfully submitted,

Scott M. Tulino, Esq.
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Date: July 19, 2005
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Attorney's Post Card Filing Receipt
Serial Number: 101 634 836 Papers Filed On: 5/16/05

Attorney's Docket Number: FU3 354-151 ☒ Patent ☐ Trademark

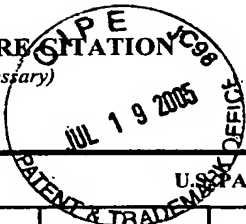
Applicant's Name: Hisaki KATO, et al, Application Filing Date: 5/16/03
Papers Filed Herewith:

- ☐ Amendment ☐ Request for Extension of Time ☐ CPA Request
- ☐ Notice of Appeal ☐ Appeal Brief (in triplicate) ☐ Reply Brief
- ☒ IDS JUL 06 2005 ☒ 1449 Form w/ 2 Documents ☐ Priority Document(s)
- ☐ Assignment ☐ Recordation Cover Sheet ☐ Formal Drawings
- ☐ Drawing Corrections ☐ Issue Fee Transmittal ☐ Missing Parts
- ☒ Other Japanese Office Action, dtd 5/24/05

Fees Filed Herewith: \$ ☐ Check ☐ Charge Deposit Account:

Hand Delivered

INFORMATION DISCLOSURE CITATION
(Use several sheets if necessary)



Docket Number (Optional)
F03-354-USDiv

Application Number
10/634,836

Applicant(s)
Hisaki KATO, et al.

Filing Date
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Group Art Unit
2822

U.S. PATENT DOCUMENTS

*EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE

U.S. PATENT APPLICATION PUBLICATIONS

*EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE

FOREIGN PATENT DOCUMENTS

	REF	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
							YES	NO
		H7-7182	01/10/99	Japan			ABS	

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

		Japanese Office Action, dated May 24, 2005, with partial English translation
		NAKAMURA, et al., "Ridge-geometry InGa _N multi-quantum-well-structure laser diodes", APPLIED PHYSICS LETTERS, September 2, 1996, Vol. 69, No. 10, pp. 1477-1479

EXAMINER

DATE CONSIDERED

EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP Section 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.